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Substitute for form 1449B/PTO				<b>Complete if Known</b>	
				Application Number	10/561,775
				Filing Date	12/20/2005
				First Named Inventor	Anatoli N. Verentchikov
				Art Unit	2800
				Examiner Name	
Sheet	1	of	2	Attorney Docket Number	LEC01 P-432

(Use as many sheets as necessary)

NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			T <sup>2</sup>
		BENJAMIN M. CHIEN, ET AL., "Plasma Source Atmospheric Pressure Ionization Detection of Liquid Injection Using an Ion Trap Storage/Reflection Time-of-flight Mass Spectrometry," <i>Anal. Chem.</i> 1993, 65, 1916-1924.			
		JOHN B. HOYES, ET AL., "A High Resolution Orthogonal TOF with Selectable Drift Length," <i>ASMS2000</i> .			
		QINCHUNG JI, ET AL., "A Segmented Ring, Cylindrical Ion Trap Source for Time-of-flight Mass Spectrometry," <i>J Am Soc Mass Spectrom</i> 1996, 7, 1009-1017.			
		ALFONZ LUCA, ET AL., "On the combination of a Linear Field Free Trap with a TOF MS," 2001 American Institute of Physics, <i>Review of Scientific Instruments</i> , Vol. 72 No. 7, July 2001, pp. 2900-2908.			
		V.I. KARATAEV, B.A. MAMYRIN, AND D.V. SHIMMIK, "New Method for Focusing Ion Bunches in TOF MS," <i>Sov. J. Tech. Phys.</i> 41 (1971) 1498, <i>Soviet Physics - Technical Physics</i> , Vol. 16, No. 7, pp. 1177-1179, (January 1972).			
		MELVIN A. PARK, ET AL., "High m/z Range, High Resolution Coaxial Multiple Reflection ESI-TOFMS," <i>Proceedings of the 49th ASMS Conference on Mass Spectrometry</i> , Chicago, IL, (May 27-31, 2001).			
		T. SAKURAI, ET AL., "A New Multi-passage Time-of-flight Mass Spectrometer at JAIST," <i>Nucl. Instr. and Meth. in Phys. Res., A</i> 427 (1999) 182-186.			
		T. SAKURAI, ET AL., "Ion Optics of a High Resolution Multipassage Mass Spectrometer with Electrostatic Ion Mirrors," <i>Nucl. Instr. and Meth. in Phys. Res., A</i> 363 (1995) 473-476.			
		H. WOLLNIK AND M. PRZEWLOKA, "Time-of-Flight Mass Spectrometers with Multiply Reflected Ion Trajectories," <i>International Journal of Mass Spectrometry and Ion Processes</i> , Vol. 96, No. 3, pp. 267-274, (April 16, 1990).			
		H. WOLLNIK, A. CASARES, "An Anergy-isochronous Multi-pass TOF MS Consisting of Two Coaxial Electrostatic Mirrors," <i>International Journal of Mass Spectrometry</i> 227 (2003) pp. 217-222.			

Examiner Signature	Date Considered
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

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## **INFORMATION DISCLOSURE STATEMENT BY APPLICANT**

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Complete If Known

Location Number 10/561-775

Date 12/20/2001

*Named Inventor* *Patent Number*

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They Name \_\_\_\_\_

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1 Application's unique creation date/decree number (continued). 2 Applicant is to place a check mark here if English Language Translation is attached.

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